

Notice of References Cited	Application/Control No. 10/551,490	Applicant(s)/Patent Under Reexamination EICHHORN ET AL.	
	Examiner Leah S. Lovell	Art Unit 2885	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,619,825	09-2003	Natsume, Kazunori	362/509
*	B	US-6,520,669	02-2003	Chen et al.	362/545
*	C	US-2003/0165061	09-2003	Martineau, Patrick M.	362/297
*	D	US-2004/0000867	01-2004	Chen, Hsing	313/512
*	E	US-4,630,180	12-1986	Muraki et al.	362/223
*	F	US-5,382,811	01-1995	Takahashi, Nozomu	257/88
*	G	US-5,779,351	07-1998	Erickson et al.	362/241
*	H	US-5,836,676	11-1998	Ando et al.	362/244
*	I	US-6,208,078	03-2001	Fujii et al.	313/510
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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